

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: S. SHIRAYONE, et al.

Application No.: 10/791,856

Filed: MARCH 4, 2004

For: METHOD FOR PROCESSING PLASMA PROCESSING APPARATUS

Group AU: 1746

Examiner: Zeinab El Arini

Confirm. No.: 5252

**AMENDMENT**

**Mail Stop: AMEND – NO FEE**

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

May 22, 2007

SIR:

In response to the Office Action mailed February 22, 2007, please amend the above-identified application as listed below and as set forth on the following pages:

AMENDMENTS TO THE SPECIFICATION;

AMENDMENTS TO THE DRAWINGS;

AMENDMENTS TO THE CLAIMS;

REMARKS are included following the amendments; and

A Replacement Sheet of drawings for Figs. 5 and 6, in an Appendix.